

DOCKET NO: 244686US3DIV

IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF :
HIROSHI IGARASHI, ET AL. : ATTN: APPLICATION DIVISION
SERIAL NO: NEW CONT. APPLICATION :
FILED: HERewith :
FOR: WAFER PROCESSING :
APPARATUS CAPABLE OF :
MAPPING WAFERS :

PRELIMINARY AMENDMENT

COMMISSIONER FOR PATENTS
ALEXANDRIA, VIRGINIA 22313

SIR:

Prior to examination on the merits, please amend the above-identified application as follows:

Amendments to the Specification begin on page 2 of this paper.

Remarks/Arguments begin on page 3 of this paper.